

Notice of References Cited	Application/Control No. 09/839,794	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Sargon N. Nano	Art Unit 2157	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,976,258	12-2005	Goyal et al.	718/104
*	B	US-6,948,003	09-2005	Newman et al.	709/250
*	C	US-6,947,384	09-2005	Bare, Ballard C.	370/235
*	D	US-6,944,786	09-2005	Kashyap, Vivek	714/4
*	E	US-6,938,031	08-2005	Zoltan et al.	707/1
*	F	US-6,839,752	01-2005	Miller et al.	709/224
*	G	US-6,779,039	08-2004	Bommareddy et al.	709/238
*	H	US-6,772,226	08-2004	Bommareddy et al.	709/245
*	I	US-6,625,152	09-2003	Monsen et al.	370/392
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.